

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q88645

Yoshiyuki FUKUMOTO, et al.

Appln. No.: 10/539,373

Group Art Unit: Not Yet Assigned

Confirmation No.: Not Yet Assigned

Examiner: Not Yet Assigned

Filed: June 16, 2005

For: MAGNETO-RESISTANCE DEVICE AND METHOD OF MANUFACTURING THE SAME
LETTER CONCERNING PTO/SB/08 A & B

Commissioner for Patents

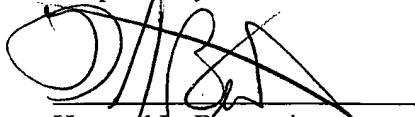
P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Applicants respectfully submit this letter to correct a typographical error on the PTO/SB/08 A & B submitted with the Information Disclosure Statement on June 16, 2005, in the above-identified application. Applicant inadvertently mistyped a reference that was cited in the specification. The reference listed as "S. Cardoso et al., Influence of Ta antidiffusion barriers on the thermal stability of tunnel junctions, Applied Physics Letters (Vol. 78, May 7, 2001, pp. 2911-2913)(the second conventional example)", should have read "Applied Physics Letters (Vol. 78, May 7, 2001, pp. 2911-2913)(the second conventional example), Zongzhi Zhang, et al.. Attached is a corrected PTO/SB/08 A & B for the Examiner to initial upon consideration of all of the references submitted on June 16, 2005.

Respectfully submitted,



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WASHINGTON OFFICE

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CUSTOMER NUMBER

Date: December 7, 2005

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